



03500.017544

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Unassigned
Yoshihiro OGAWA, et al.	)	
	:	Group Art Unit: 2878
Application No.: 10/657,224	)	
	:	
Filed: September 9, 2003	)	
	:	
For: RADIATION CONVERTING	)	
SUBSTRATE, RADIATION	:	
IMAGE PICKUP APPARATUS	)	
AND RADIATION IMAGE	:	
PICKUP SYSTEM	)	January 9, 2004

Mail Stop Missing Parts  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED FILING RECEIPT

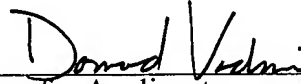
Sir:

Applicants have received an official Filing Receipt in the above-identified application which incorrectly lists the filing date of the foreign priority application as "9/11/2001." The filing date should read --9/11/2002--, as shown in red on the attached marked-up copy of the Filing Receipt.

Accordingly, Applicants respectfully request issuance of a corrected Filing Receipt.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Damond Vadnais", written over a horizontal line.

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## UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/657,224	09/09/2003	2878	750	03500.017544	2	10	2

CONFIRMATION NO. 8834

## FILING RECEIPT



\*OC000000011396691\*

Date Mailed: 12/02/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

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 Kengo Emoto, Kanagawa, JAPAN;

## Assignment For Published Patent Application

Canon Kabushiki Kaisha, Tokyo, JAPAN;

## Domestic Priority data as claimed by applicant

## Foreign Applications

JAPAN 2002-265572 ~~09/11/2001~~ 09/11/2002

If Required, Foreign Filing License Granted: 12/02/2003

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

## Title

Radiation converting substrate, radiation image pickup apparatus and radiation image pickup system

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Title 35, United States Code, Section 184  
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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